## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hidemasa KAI

Group Art Unit: 1763

Application Number: 10/626,675

Examiner: Ram N. Kackar

Filed: July 25, 2003

Confirmation Number: 1831

For:

EPITAXIAL WAFER PRODUCTION APPARATUS AND

SUSCEPTOR STRUCTURE

Attorney Docket Number:

030901

Customer Number:

38834

## AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

February 14, 2007

Sir:

In response to the Office Action dated November 14, 2006, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.